

10/088098

FILED UNDER 35 U.S.C. 371

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10088098	FILING DATE 05/30/2002	CLASS 219	SUBCLASS 444.100	GAU 3742	EXAMINER Pat Fagua
<b>**APPLICANTS:</b> Ito Yasutaka; Hiramatsu Yasuji;					
<b>BEST AVAILABLE COPY</b>					
<b>**CONTINUING DATA VERIFIED:</b> THIS APPLICATION IS A 371 OF PCT/JP01/06395 07/25/2001 JF					
<b>** FOREIGN APPLICATIONS VERIFIED:</b> JAPAN 2000-223767 07/25/2000 JF					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO			
35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		221158US2PCT			
Verified and Acknowledged Examiners's initials JF					
TITLE : Ceramic substrate for semiconductor manufacture/inspection apparatus, ceramic heater, electrostatic clampless holder, and substrate for wafer prober					

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
Assistant Examiner			
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.
			Print Fig:
Primary Examiner		Application Examiner	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	
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